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AF
LIC 9/11/06
ENTERED
PLEASE
**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE
GROUP 1763
PATENT APPLICATION**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q77312

Hiroshi TANABE, et al.

Appln. No.: 10/674,396

Group Art Unit: 1763

Confirmation No.: 4416

Examiner: Karla A. MOORE

Filed: October 1, 2003

For: SEMICONDUCTOR MANUFACTURING APPARATUS AND MANUFACTURING
METHOD OF THIN FILM SEMICONDUCTOR DEVICE

RESPONSE UNDER 37 C.F.R. § 1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 26, 2006, please consider the remarks as follows on the accompanying pages.

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